



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **MAIL STOP: AMENDMENT**
Akihisa HONGO et al. : **Confirmation No. 9165**
Serial No. 10/620,452 : Docket No. 2003_0979
Filed July 17, 2003 : Group Art Unit 1765
WAFER CLEANING APPARATUS : Examiner L. VIHN

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

Sir:

Responsive to the Office Action mailed March 3, 2005, the time for responding thereto being extended for two months in accordance with a Petition for Extension submitted herewith, please amend the above-identified application as follows: